



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The application of : Confirmation No. 5534

Masayoshi HIROSE et al. : Docket No. 2001-0386

Serial No. 09/821,046 : Group Art Unit 3724

Filed February 28, 2002 : Examiner Timothy V. Eley

POLISHING APPARATUS INCLUDING  
TURNTABLE WITH POLISHING SURFACE  
OF DIFFERENT HEIGHTS : **MAIL STOP: AMENDMENT**

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AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 23, 2005, the period for response to which having been extended by one month to July 23, 2005, kindly amend the above-referenced U.S. patent application as follows: